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MEMC 98-5751 (2358.4) PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Mutti et al.
Serial No. 10/008,812
Filed November 13, 2001
For METHOD FOR CONTROLLING GROWTH OF A SILICON CRYSTAL TO MINIMIZE GROWTH RATE AND DIAMETER DEVIATIONS

November 20, 2003

EL998652207US

LETTER TO THE OFFICIAL DRAFTSMAN

TO THE COMMISSIONER FOR PATENTS,

SIR:

Submitted herewith are five (5) sheets of formal drawings to replace the drawings now on file.

The Commissioner is hereby authorized to charge any fees that may be required during the entire pendency of this application to Deposit Account No. 19-1345.

Respectfully submitted,

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O(X)XXX	Patent/Reg. No
The following has been received by the U.S. Patent and Trademark Office on the date stamped hereon.	
☐ Amendment	☐ Fee Transmittal Form
☐ Preliminary Amendment	☐ Combined Declaration/Power of Attorney ☐ Notice of Appeal
☐ Response to Missing Parts Notice	☐ Status Inquiry
☐ Assignment and Cover Sheet	□ IDS, PTO/SB/08A, Reference(s)
□ Brief	Sheet(s) of Formal Drawing(s)
☐ Check \$	☐ Letter to Official Draftsman
☐ Letter to Commissioner	☐ Issue Fee/PTO-85b/Certificate of Mailing
☐ RCE Transmittal	□ Publication Fee
☐ Maintenance Fee	□ Statement of Use □ Statement
Section Declaration	Extension of Time to Opposit
Other Setter to Official D	introduce ?
Other	TOENA

